

ATTORNEY DOCKET NO. 92-C-074D1 (STMI01-00024)

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of : Frank Randolph Bryant  
United States Serial No. : to be assigned  
Filing Date : to be assigned  
Prior United States Serial No. : 08/159,461  
Prior Filing Date : November 30, 1993  
Prior Examiner : R. Booth  
Prior Group Art Unit : 1107  
Title : TRANSISTOR STRUCTURE AND METHOD FOR  
MAKING SAME

Assistant Commissioner for Patents  
Box Patent Application  
Washington, D. C. 20231

Dear Sir:

<p align="center"><b>CERTIFICATE OF MAILING</b></p> <p align="center">Express Mail Certificate No. EL 749594003 US</p> <p>I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Box Patent Application, Washington, D.C. 20231, on <u>May 16, 2001</u>.</p> <p><u>KATHY LONGENECKER</u> (Printed or typed name of person signing the certificate)</p> <p><u>Kathy Longenecker</u> (Signature of the person signing the certificate)</p>
---

INFORMATION DISCLOSURE STATEMENT

Pursuant to the duty of disclosure under 37 C.F.R. § 1.56, Applicant submits this statement. This submittal is made in accordance with 37 C.F.R. §§ 1.97 and 1.98 and § 609 of the Manual of Patent Examining Procedure. The patents, publications and other information herein are listed below and on the attached Form PTO-1449. Copies of the listed references are submitted herewith.

#5/105  
Dking  
1/16/02



DOCKET NO. 92-C-074D1 (STMI01-00024)  
PATENT

<u>U.S. Patent No.</u>	<u>Inventor</u>	<u>Date</u>
3,576,478	Watkins, et al.	04/27/1971
3,892,891	Goodman, et al.	07/01/1975
3,898,105	Mai, et al.	08/05/1975
3,899,363	Dennard, et al.	08/12/1975
3,909,304	Cho	09/30/1975
3,913,126	Hooker, et al.	10/14/1975
3,913,211	Seeds, et al.	10/21/1975
3,943,542	Ho, et al.	03/09/1976
3,958,323	De La Moneda	05/25/1976
3,966,501	Nomura, et al.	06/29/1976
3,996,658	Takei, et al.	12/14/1975
4,013,484	Boleky, et al.	03/22/1977
4,023,195	Richman	05/10/1977
4,039,359	Nakamoto	08/02/1977
4,045,249	Hotta	08/30/1977
4,075,045	Rideout	02/21/1978
4,092,661	Watrous, Jr.	05/30/1978
4,112,575	Fu, et al.	09/12/1978
4,113,533	Okumura, et al.	09/12/1978
4,179,311	Athanas	12/18/1979
4,322,881	Enomoto, et al.	04/06/1982
4,553,314	Chan, et al.	11/19/1985

<u>Foreign Patent No.</u>	<u>Country</u>	<u>Date</u>
1421363	Great Britain	01/14/1976
1428713	Great Britain	03/17/1976
51-39835	Japan	09/28/1973
51-12507	Japan	07/12/1973
51-41515	Japan	08/25/1973
51-118392	Japan	1975
51-118393	Japan	1975
52-42670	Japan	07/21/1975
60-785	Japan	04/15/1977

Publications

C.R. Fritzsche, et al., "Thermal Oxidation of Silicon after Ion Implantation," Vol. 120, No. 11, pp. 1603-1605, 1973.

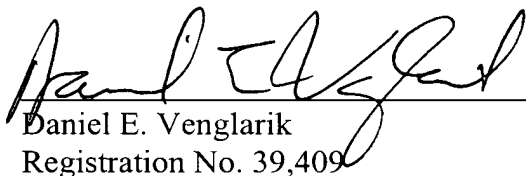
K. Nomura, et al., "Enhanced Oxidation of Silicon by Ion Implantation and its Novel Applications," 1974, pp. 681-688.

Applicant hereby expressly reserves the right to swear behind the effective dates of any of the above Patents and to question the relevance and materiality of the Patents and Publications listed herein, in whole, in part, or in combination, subsequent to filing this Information Disclosure Statement.

Respectfully submitted,

NOVAKOV DAVIS & MUNCK, P.C.

Date: 5-16-01

  
Daniel E. Venglarik  
Registration No. 39,409

900 Three Galleria Tower  
13155 Noel Road  
Dallas, Texas 75240  
Telephone: (214) 922-9221  
Facsimile: (214) 969-7557  
email: [dvenglarik@novakov.com](mailto:dvenglarik@novakov.com)